

## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

### Title of Invention

METHOD AND SYSTEM FOR DYNAMIC MODELING AND  
RECIPE OPTIMIZATION OF SEMICONDUCTOR ETCH  
PROCESSES

Application Number : 10/523777  
Confirmation Number: 5732  
First Named Applicant: Kun Li  
Attorney Docket Number: VOY007US  
Art Unit: 2825  
Examiner:  
Search string: ( 6133132 ).pn



### US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6133132	2000-10-17	Toprac et al.			

### Signature

Examiner Name	Date